

TRANSMITTAL LETTER  
(General - Patent Pending)

Docket No.  
11675.114

In Re Application Of: Kei-Yu Ko



Serial No. 08/846,671 Filing Date April 30, 1997 Examiner George A. Goudreau Group Art Unit 1765

Title: UNDOPED SILICON DIOXIDE AS ETCH STOP FOR SELECTIVE ETCH OF  
DOPED SILICON DIOXIDE

RECEIVED  
U.S. PATENT & TRADEMARK OFFICE  
MAY 30 2000  
TC 1765 MAIL ROOM  
ATTN: P. R. Huft  
6/18/00  
MW

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Combined Amendment and Petition for Extension of Time (2 pgs); Amendment B (15 pgs); Copy of English Translation of Japanese patent; Check No. 115701 in the amount of \$110; Postcard

in the above identified application.

- No additional fee is required.
- A check in the amount of \$110.00 is attached.
- The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 23-3178 as described below. A duplicate copy of this sheet is enclosed.
  - Charge the amount of
  - Credit any overpayment.
  - Charge any additional fee required.

  
Signature

Bradley K. DeSandro, Reg. No. 34,521



022901

PATENT TRADEMARK OFFICE

Dated: May 25, 2000

I certify that this document and fee is being deposited on May 25, 2000 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

  
Signature of Person Mailing Correspondence

Peggy R. Huft

Typed or Printed Name of Person Mailing Correspondence

CC: